

09/554629

422 Rec'd T/PTO 16 MAY 2000

Attorney Docket No. 00336/LH

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Shinji NAKAHARA
Masato IMAI
Masanori MAYASUMI
Kazutoshi INOUE

Serial No. : To be assigned (U.S.
National Phase of
PCT/JP98/05212, filed
November 11, 1998)

Filed : Concurrently herewith

For : DEVICE FOR HOLDING
SEMICONDUCTOR WAFER

Art Unit :

Examiner :

Express Mail Mailing Label
No.: EL 484 825 972 US
Date of Deposit: May 16, 2000
I hereby certify that this paper is
being deposited with the United States
Postal Service "Express Mail Post Office
to Addressee" service under 37 CFR 1.10
on the date indicated above and is
addressed to the Assistant Commissioner
for Patents, Washington, D.C. 20231

St. Thanne Franklin
St. Thanne Franklin

In the event that this Paper is late
filed, and the necessary petition for
extension of time is not filed
concurrently herewith, please consider
this as a Petition for the requisite
extension of time, and to the extent not
tendered by check attached hereto,
authorization to charge the extension
fee, or any other fee
required in connection with this Paper
to Account No. 06-1378.

FA
C.F.
3/28/01

PRELIMINARY AMENDMENT

Attention: BOX PCT
Assistant Commissioner for Patents
Washington, D.C. 20231

S I R :

Please amend the above-identified application as follows:

IN THE SPECIFICATION:

Page 9, line 29, change "exerting a holding force of" to
--being adapted to act against said
peripheral edge of said wafer to exert a
holding force toward the center of said
wafer in--.

Page 10, line 5, after "the" (second occurrence) insert
--force of--;